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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: I. Soward
Haruhito ONO et al.)	
	:	Group Art Unit: 2822
Application No.: 09/819,737)	
	:	Confirmation No.: 4343
Filed: March 29, 2001)	
	:	Allowed: July 13, 2001
For: ELECTROOPTIC SYSTEM ARRAY,)	
CHARGED-PARTICLE BEAM	:	July 27, 2004
EXPOSURE APPARATUS USING THE)	
SAME, AND DEVICE	:	
MANUFACTURING METHOD)	

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED NOTICE OF ALLOWANCE

Sir:

Applicants have received a Notice of Allowance and a Notice of Allowability dated July 13, 2004, in the above-identified application, in which the Notice of Allowance lists the TITLE OF INVENTION as "ELECTROOPTIC SYSTEM ARRAY, CHARGED-PARTICLE BEAM EXPOSURE APPARATUS USING THE SAME, AND DEVI MANUFACTURING METHOD."

The title as listed contains a misspelled word. Specifically, the twelfth word "DEVI" should read -- DEVICE --. Applicants, therefore, request that the TITLE OF THE INVENTION be corrected to read -- ELECTROOPTIC SYSTEM ARRAY, CHARGED-PARTICLE BEAM

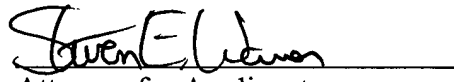
EXPOSURE APPARATUS USING THE SAME, AND **DEVICE** MANUFACTURING

METHOD --. Accordingly, Applicants request that a corrected Notice of Allowance be issued to make this correction.

Applicants believe that no fees should be incurred in connection with filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be associated therewith. A duplicate of this document is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our below-listed address.

Respectfully submitted,


Attorney for Applicants
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Registration No. 33,326

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